

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Hiroshi, et al.  
Appl. No.: 10/563,630  
Conf. No.: 1962  
Filed: March 6, 2006  
Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR  
PREPARATION THEREOF  
Art Unit: 2811  
Examiner: Unknown  
Docket No.: 113184-114

Commissioner for Patents  
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**PRELIMINARY AMENDMENT**

Sir:

Please amend the above-identified patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin on page 3 of this paper.